Body Centered Cubic Structure:

*In BCC Unit Cell, & corner atoms and I body center atom are available.

* Each Corner atom is Shared by & adjacent unit cells.

* Body center atom Completely belongs to a single unit cell.

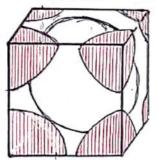
No. of atoms per unit cell: Corner atom = 8x = 1 Body center atom = 1

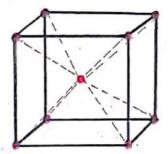
". Total no of atoms per = 1+1=2 unit cell

Co-Ordination Number:

In BCC each body centered atom is surrounded by & closest Cornel atom along its diagonal.

.. Coordination Number = 8

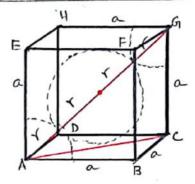




Atomic Radius (n:

*In Bcc, closest and longest bond consider between any two corner atoms and Body center atom along its body diagonal.

* From the diagram consider a body diagonal AG' of an unit cell.



From the diagram, DACG AG= Act CG MKG, AG = 47, CG=a and Ac2 = AB2+Bc2 In which, AB=a, Bc=a ". AG2 = AB2+ Bc2+ CG2 (Ar) = a2+a2+a2 16x2=3a2 2 12= 3 a2 Y= Ba

Packing Factors-

PF = No. of atoms x Vol- of an atom

Vol. of unit cell

No of atoms perz = 2

Atomic radius Y= 13 a.

Volume of an unit cell V = a3

 $PF = \frac{2 \times 4/3 \pi (3a)^3}{a^3}$

PF = V311 = 0.68

(ie) In BCC 68.1. space in an unit cell occupied by atoms and 32%. of the space is vacant.

Face Centered Cubic [FCC]

In FCC, Structure, the unit cell has 8 corner atoms and one atom at the centre of each face.

* It is one of the Closely packed Structures.

No. of atoms per unit cell:

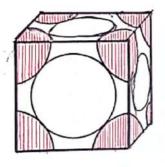
AIn FCC unit cell, Cornel atom is Shared by 8 adjacent unit cells.

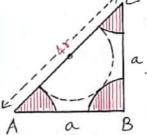
". No of corner atoms = $8 \times \frac{1}{8} = 1$

* Each face center atom shared by 2 other unit cells.

.. No of face center atoms=6x1 = 3.

j. Total no of atoms = 1+3= 1+3





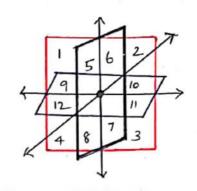
Co-ordination Number:

*In FCC, each corner atom Surrounded by 4 face center atom in an axis plane [x,y,z]

X- Plane [1,2,3,4], Y-Plane [5,6,7,8]

Z-Plane [9,10,11,12].

.°. Total no of neavest atoms =4+4+4=12



Atomic Radius:

In FCC, each face center atom. has abond between two corner atom through its face diagonal.

In DABC,

$$Ac^{2} = AB^{2} + Bc^{2}$$

$$(4r)^{2} = a^{2} + a^{2}$$

$$16r^{2} = 2a^{2}$$

$$r^{2} = \sqrt[3]{16}$$

$$r = \sqrt[3]{2}$$

Atomic Packing Factory

PF = : No. of atoms x vol. of 1 atom vol. of unit cell.

No. of atoms = 4

Radius = Ba
4.

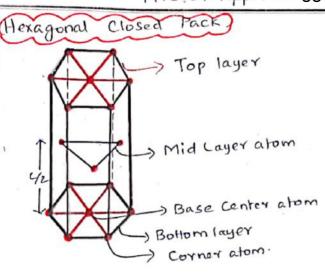
Volume $V = a^3$ $PF = \frac{4 \times 4/3\pi Y^3}{a^3}$

 $PF = \frac{4 \times \frac{4}{3} \times \Pi \left(\frac{\sqrt{2} a^3}{4} \right)^3}{a^3}$

PF = T1/2 = 0.74

In FCC unit cell, \$74.1. volume is
Occupied by atom, 26.1. is vacant.

Subject Code/Title: P#3251-Mat · Science Unit: Crystallography



* Unit cell of HCP consists of 3 layers and 3 different atoms. * It has one atom at each Corner of the hexagon totally 12 corner atoms.

* One atom at the center of the Rexagon plane (ie base).

.. There are two base centre atoms.

* 3 atoms at C/2 distance from .

top or bottom. They are completely inside the unit cell.

No-of atoms per unit cell:

In HCP, each corner atom is Shared by 6 unit cells.

". No. of corner atoms = $6 \times \frac{1}{6} = 1$ (in top layer)

111'y we have same no of atoms in bottom layer.

. Total no of corner] = 1+1 = 2

Each base centred atom is shared by 2 unit cells.

.. No of base centre atom = 2x 1 =1,

All 3 mid layer atoms Completely placed inside an unit cell.

.. No of mid layer atom = 3

per unit cell = 2+1+3=16

Atomic Radius:

Any two corner atoms form a closest bond by touching each other

., 2r=a

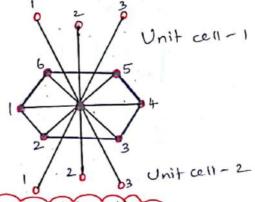
Y = 0/2

Coordination Number:

* A base center atom will touch all 6 surrounding corner atoms.

* And also, it is in contact with 3 mid layer atoms in the hap unit cell and 3 mid layer atoms in the bottom unit cells.

.. Coordination no = 3+3+6 = 12



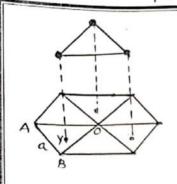
C/a Ratio Calculation

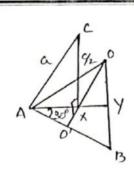
Let c' be the height of the unit cell.

Consider atmangle ABO above which center atom 'c' lies at a distance 4/2.

Subject Code/Title:

PH 3251-Mat-Science PH 3259-App. Mat Supprese.com Unit: Crystallography





Here Ay' is drawn I' to Bo' and 'x' is the inter point above which center atom is located.

In DABY

$$Ay = \frac{ar_3}{2} - 0$$

'X' is the center of DABO

$$\therefore Ax = \frac{2}{3}Ay - \bigcirc$$

In DAXC

$$\alpha^2 = \left[\frac{\alpha}{\sqrt{3}}\right]^2 + \left(\frac{c}{2}\right)^2$$

$$a^2 = \frac{a^2 + c^2}{3}$$

$$\frac{c^{2}}{4} = \alpha^{2} - \frac{\alpha^{2}}{3} = \frac{3\alpha^{2} - \alpha^{2}}{3}$$

$$\frac{c^2}{4} = \frac{2a^2}{3}$$

$$\frac{c^2}{a^2} = \frac{8}{3}$$

$$\frac{C}{a} = \sqrt{\frac{8}{3}}$$

Packing Factor

Volume of any = Height Area of base unit cell

Volu

Atomic Packing ? Vol. of atoms Factor J Vol. of unit cell.

$$APF = \frac{\pi a^{3}}{3\sqrt{3}a^{2}c} = \pi a^{3} \times \frac{2}{3\sqrt{3}a^{2}c}$$

$$= \frac{2\pi}{3\sqrt{3}} \cdot \left(\frac{a}{c}\right)$$

$$= \frac{2\pi}{3\sqrt{3}} \cdot \left(\frac{a}{\sqrt{6}}\right)$$

.. For HCP unit all 74.1, Space is atom and 26.1, space is vaccant.

Crystal Imperfections:

If atoms in solid are not arranged in a perfectly regular manner, it is called defects in crystal.

Types

* (Point Defects)

- Vacancies
- Interstitial Defects
- Impurity Defects.
- Impurit

* Line Defects

- Edge Dislocation
- Screw Dislocation.

* Surface Defects

- Grain Boundaries
- Tilt Boundaries
- -Twin Boundaries
- Stacking Faults.

* Nolume Defects

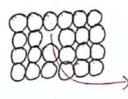
- Crack.

Point Defects:

Due to imperfect packing of atoms during crystallisation.

Vacancies: -)

It refers to a missing atom.



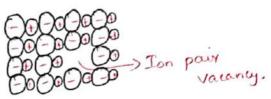
-) Wacancy -

There are two types of vacancies Foreign Interstitial

- (1) Schottky Defect.
- (i) Frenkel Defect.

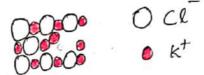
Schottky Defect:

It refers to the missing of a pair of positive and regative ions in an ionic crystal.



Frenkel Defect:

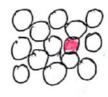
A vacancy associated with interstitial impurity is called Frenkel defect.



Interstitial Defect

Self Interstitial

If an atom from same Crystal occupies interstitic site it is called Self interstitial





) Impurity.

Self Interstitial

Foreign Interstitul

If an impurity atom Occupies interstitic site it is Called foreign interstiticl.

Unit: Crystallography

Impurities:

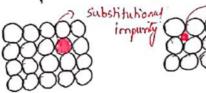
Adding of foreign atoms to Orystal lattice is known as impurity defects

Substitutional impurity Defect:

* Foreign atom replaces like parent atom.

Interstitial Impurity Defect

Small size foreign atom Occupies the empty Space in the parent Crystal,). Interstitial





impunity

Line Defecty

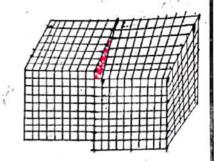
A portion of a line of atoms is missing or displaced from its regular size.

Types:

Edge Dislocation. Screw Dislocation.

Edge Dislocation!

In this type one of the atomic planes does not extend through the entire crystal.



Screw Dislocation

It is due to a displacement of atoms in one part of a crystal relative to rest of the crystal.

Surface Defects;

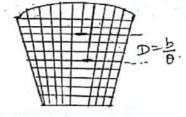
In this type, the defects takes place in the surface of Crystal.

Grain Boundary:

It is the boundary in the gravis at which the atomic arrangement one side is mirror Image of the atoms on the other side

Till Boundary

It is an array of parallel edge dislocation

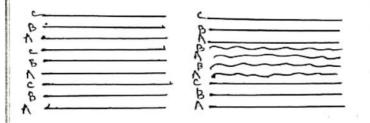


Stacking Faults

Whenever the Stacking of atoms is not in proper sequence Subject Code/Title: PH 3251 - Mat - Science.

PH 3259 - App. MEnggree Com: Crystallography

throughout the crystal, defect in called stacking fault.



Plastic Doformation Mechanism:

Plastic Deformation of a single Crystal occurs in two ways 1. Slip 2. Twinning.

Sup:

The deformation by slip takes place when one part of the crystal moves or glides over another part along certain planes.

Mechanisms of Slip

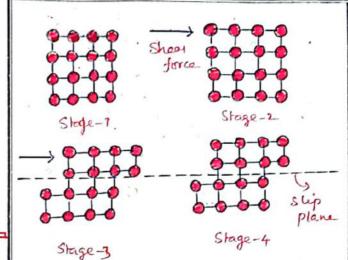
There are 4 stages during plastic deformation of single crystal by the slip.

Stage: 1 -> Perfect Crystal willtout Slip.

Stage: 2 -> Deforming shear force is applied to the crystal.

Stage: 3 -> Stip taking place along the Stip plane

Stage: 4 > Permanent deformation when deforming forces are removed.



The posticular Crystallographic planes where slip occurs are called slip planes. The preferable direction along which slip occurs is called the slip direction.

Twinning:

The Shear forces produce atomic displacements Such that the deformed lattice forms a mirror image of the undeformed lattice.

(ie) The atoms on one side of the plane location is in mirror image position of the atoms on the other side.

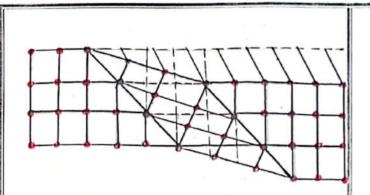
The crystallographic plane of symmetry between the deformed and undeformed parts of the metal lattice is called the twinning plane.

Subject Code/Title: PH3251 - Mat - Science.

PH3251 - Mat - Science.

PH3259 - App MaEnggTreescom

Unit: Crystallography



Types of Twins;

1. Mechanical Twins

2. Annealizing Turins.

Mechanical Twins:

These turns are produced by mechanical deformation. These turns are produced by BCC & HCP Crystals.

Annealing Twins:

These furins are produced by annealing process. The are usually broader and produced mostly in FCC crystals.



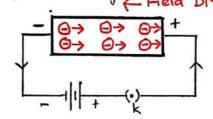
Definition:

It is the quantity of Electrico Charges flowing per unit time (t)

per unit area (A) maintained at
a unit potential gradient (E).

Derivation:

When an electrical field applied to an electron of charge 'e', It moves in a opposite direction with the applied field with a constant velocity (Ja) known as "drift velocity" (Field Direction



Here the force experienced by the electron by external field

and the accoleration gained by the electron 'a' is given by acceleration $a = \frac{\text{velocity}}{\text{Time}} = \frac{\text{vel}}{\text{T}}$

We know that from Newton's II law

By comparing eans (1) & (3)

Substituting eqn (2) in eqn (1)

If $n \rightarrow n0$, of free electron $e \rightarrow charge$ of an electron

Then current density interms of

Substitute eqn (5) in eqn (6)

$$J = \frac{ne^2 E I}{m} - 9$$

From the definition of Charge density is directly proportional to applied electric field.

Comparing eqns O & B we get

Egn (1) is the expression for the electrical conductivity.

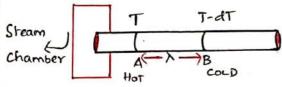
Thermal Conductionty:) (Definition:)

It is the amount of heat Conducted per unit area (A), per unit time (t) maintained at unit temperature gradient

$$k = \frac{Q}{dT/dx} = \frac{n o^2 k_B T}{2}$$

Derivation:

Consider a unifor metallic rod contain free electron.



Here A&B -> Cross-sectional

area near Rot& codd end

T, T-dT -) Temp at A&B.

A -> Mean free path:

The average K.E of electrons

Crossing A

$$E_1 = \frac{1}{2}mo^2 = \frac{3}{2}k_BT' - 0$$

1118 K.E of freedectron at 'B'

Excess energy carried out by electrons from A to B

Assume, the electron can move in all possible direction, then the no. of electron crossing per unit area, per unit time from unit area, per unit time from 'B'.

.. The excess average energy carried from A to B is given by

Hence the net amount of heat transformed from A' to B'.

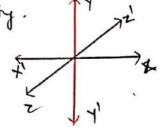
from the definition, we know that

$$Q = K \cdot \frac{dT}{\lambda} - \widehat{F}$$

By comparing eqn 7 &6

WKt >= TO

Egn @ is the expression for thermal conductivity.



Fermi Distribution function:

Definition: It is the probability of occupation of electrons among different energy

levels at absolute temperature..

When E -> Energy level to be considered.

Er > Fermi energy lovel.

Ka-> Boltzmann Constant T > Absolute Temperature.

If FCE)=1, the energy level is occupied by an electron.

If FCED=0, the energy level is Vaccant

If F(E) = 0.5, then there is 50%. chance for the electron to occupy.

Case (i)

If EKEf at TOK Then FCE) = 1 1+0(E-Ef)/kBT = (E-Ep)/0

FCE) = 1

Thus at T=ok, 100%. chance for the electrons to occupy the energy levels.

 $=\frac{1}{14000}=\frac{1}{140}=1$

case (ii)

If
$$T = OK$$
 at $E > E_F$
Then $F(E) = \frac{1}{1 + e^{(E-E_F)/k_BT}}$
 $= \frac{1}{1 + e^{\alpha}} = \frac{1}{1 + \alpha v}$

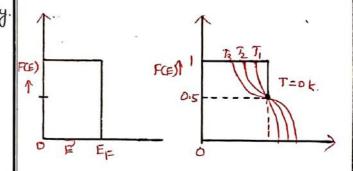
Thus D.J. Chance for the electrom to occupy the energy levels

case (iii)

If TYOK at E=EF F(E) = 1 = 1 1+e° 1+1

 $F(E) = \frac{1}{2}$ or F(E) = 0.5

There is 50%. Chance for the electrons to occupy the fermi elaergy level



Variation of Ep with Yespect to temperature.

When T=OK, occupation is upto Ex When TOK valence electrons got breakdown in its bond and to conduction band. exited



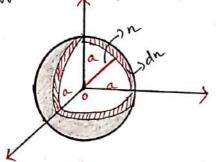
of available energy states presented per unit volume of a metal piece.

NCE) dE = NCE) dE

 $Z(E)dE = \frac{N(E)dE}{V}$

Density of = No. of avaliable energy

Energy States A Volume of a metal.



Let us consider a sphere inside a cubical metal piece of side 'a'.

- * Here nx, ny, nz are the coordinate axes.
- * n -> inner radius of the sphere.
- of the sphere.
- * The sphere consists of no. of Shells, between inner and outer Shell each represents a energy cevel.

The no of available energy States within the thickness of the Sphere of radius 'n'

$$n = \frac{1}{8} \left[\frac{4\pi}{3} \text{m}^3 \right] - 0$$

lily the energy states within the sphere of radius (n+dn)

$$n+dn = \frac{1}{8} \left[\frac{4}{3} \pi (n+dn)^{3} \right] - 2$$

Hence, the no. of avaliable energy States between (n & n+dn) the energy interval E and E+dE.

N(E)
$$dE = \frac{1}{8} \left[\frac{4}{3} \pi (n + dn)^3 - \frac{4}{3} \pi n^3 \right]$$

= $\frac{1}{8} \left[\frac{4}{3} \pi (n^3 + 3n^3 dn + 3n dn^3 + dn^3 +$

NCE)
$$dE = \frac{1}{8} \left[\frac{4}{3} \pi \left(3n^2 dn + 3n dn^2 + dn^3 \right) \right]$$

odn very small, neglecting the higher orders,

N(E)
$$dE = \frac{1}{8} \left(\frac{4}{3} \pi \left(3n^2 dn \right) \right)$$

He know that

the energy of an electron in a cubical metal piece. of side 'a' is

Differentiating eqn @ we have $dE = \frac{2n \, dn \cdot h^2}{8ma^2}$

From egn (4)

Hence eqn 3 can be written as

NCE) dE = In.ndn - 1

By substituting eqn (& v () wif

NCE) $dE = \frac{\pi}{2} \left(\frac{8 \text{ m}}{h} \right)^{\frac{1}{2}} \frac{8 \text{ ma}^2 dE}{2 \text{ h}^2}$

Here a3= V -> volume

:. Density of energy states

ZCE) dE = NCE) dE

ZCE) dE = T (8m)3/2 / E 1/2 dE

ZCE) dE = 1 (8m)3/2 E1/2 dE - 9

According to Pauli's exclusion

Principle in each state 2 electrons

Can be accommodated.

: ZCE) dE = 2 × NCE) dE

.. ZCE) dE = & XII (8m) 3/2 E 1/2 dE

ZCE) dE = T (8m)3/2 E1/2 dE - 10

Carrier Concentration in Metals:

The no of electrons per unit

volume in a given energy interval is

Calculated by

nc = JZCE) FCE) dE -

we know that

Z(E) dE = II (8m)3/2 E1/2 dE

$$= \frac{\pi}{2h^{3}} (8)^{3/2} (m)^{3/2} E^{1/2} dE$$

$$= \frac{\pi}{2h^{3}} (4)^{3/2} (2)^{3/2} (m)^{3/2} E^{1/2} dE$$

$$= \frac{\pi}{2h^{3}} a^{3} (am)^{3/2} E^{1/2} dE$$

$$Z(E)dE = \frac{411}{h^3} (2m)^{3/2} E^{1/2} dE - (2)$$

If FCE)=1 for energy levels E=0 to E=Efo

Then eqn (i) becomes f_{t} $n_{c} = \frac{4\pi}{13} (2m)^{3/2} \int E^{1/2} dE$

 $n_c = \frac{4T}{h_1^3} (am)^{3/2} \left[\frac{E^{3/2}}{3/2} \right]_0^{E_{50}}$

 $=\frac{411}{13}(2m)^{3/2}.\frac{2}{3}(E_{F_0})^{3/2}$

Fermi Energy:

From eqn (3), we know that the carrier concentration of an be written as

$$n_c = \frac{8\pi}{3h^3} (2m)^{3/2} (E_{Fo})^{3/2}$$

By raising power on bothsides

by
$$\frac{2}{3}$$

$$E_{F_0} = \left[\frac{3n_c}{8\pi} \frac{h^3}{(4\pi)^3/2} \right]^{2/3}.$$

Effective Mass of Electron? Definition:

The mass acquired by an electron, when it is accelerated in a periodic potential is called effective mass (m*)

Derivation:-

Consider a crystal subjected to electric field CE). Then the velocity gained by the electrons(v) It is described by the wave vector (K) & it is equivalent to the wave packet moving with a group velocity (0g).

$$v_g = \frac{d\omega}{dk} - 0$$

 $\omega \rightarrow \text{angular velocity } (2\pi^2)$ K-) wave vector.

we know that

w that
$$E = h^{\Omega} \qquad \text{(or)} \quad \omega = d \pi \lambda$$

$$S = \frac{\omega}{d \pi}$$

$$E = \frac{h^{\Omega}}{d \pi}$$

$$E = +\omega$$
 $h = \frac{h}{2\pi}$

: Eqn O can be written as

Under this Condition the acceleration b' of an electron

$$a = \frac{1}{h} \frac{d^2 E}{dk^2} \cdot \frac{dk}{dk} - 4$$

The momentum of an electron from de-Broglie wave langth

$$P = \frac{h}{\lambda}$$

Differentiate egn 5 w.r.t. 't'

Force acting on the electron F= dp dt

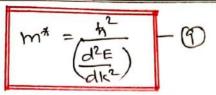
Hence egn @ can be written as

$$F = \left(\frac{t^2}{d^2E}\right) a - \left(\frac{d^2E}{dk^2}\right)$$

When an electric field is applied, acceleration of the electron due to field.

Comparing eans () & (B)

$$m*_a = \left(\frac{t^2}{d^2E_L}\right) a$$



Eqn $9 \Rightarrow$ Effective mass of an electron is not constant, but depends on the value $\frac{d^LE}{dk^2}$

Case(i):
$$\frac{d^2E}{dk^2}$$
 = +ve, m^{\dagger} = +ve

Case (iii)
$$\frac{d^2E}{dk^2}$$
 -more, ·m* is ligher

Case (iii) d2= -> loss m* is large

Tight Binding Approximation:

Before discussing about the tight binding approximation, let us know about free electron approximation.

Free electron approximation:

In solids, ionic core which are tightly bounded to lattice location exists. The electrons are free to move throughout the solid. This is called the free electron approximation.

In free electron approximation,

* The P.E of the e is assumed to
be lesser than its total energy.

* The width of the band gap (Eg) are

Smaller than the allowed band. (fig)

* The interaction between the neighbouring

atoms will be very strong.

* As the atoms are closer to each other, the inter atomic distance decrosses and hence the wave functions overlap with each other.

Free electric Tight approximation princip as a spreading as a spreadi

Tight binding approximation;

elec appr

appr.

Instead of beginning with the solid core, we begin with the electrons, (ie) all the electrons are bounded to the atoms. In otherwords, atoms are free while the electrons are tightly bounded. This is called tight bound approximation.

In tight binding approximation:

* The P.E of the electrons is
nearly equal to the total energy

* The width of the forbidden
bands (Eg) are larger than the allowed
bands.

Therfore the interactions between
the neighbouring atom will be week.

As the atoms are not closer,
the interatomic distance increases
and hence the wave functions
will not overlap.

Dia, Para, Ferro Magr Dia	Para	Ferro
i) It is non-magnetic material consits of no-permanent dipoles	Temporary magnetic material, consits of permanent depole	Permanent magnetic material. Consits of large no. of permanent dipoles.
ii) Dipoles are opposite to each other in the absence of external field. Net dipole moment is zero	of external field. Net	Dipole are oriented parallel to each other, in the absence of external field net depole moment is large.
iii) In the presence of external field depoils allign opposite to the external field.	In the presence of external field dipoles allign parallel to the external field.	Here also, dipoles allign parallel to the external field.
iv) Magnotic flux lines are repelled out of the material. Bin (But	Magnetic flux lines are attracted by the material Bin >> Bout	Magnetic flux lines are attracted maximum by the material. Bin >>> Bout
than I and susceptibility is -ve ucci, $\chi = -ve$	tre, usi, x=+ve	greater than 1, susceptibility is the , M>>1, N=+10
ii)Independent on temperature	Dependent on temperatur	Dependent on temperatu
vii) At very low temp. ît will be in diamagnetic	Temp above maximum para mag. converted unto Dia mag. is Icnown: as	Above curie temperature it is converted in to para materials
Ex: Bismulb, Gold,	Ex: Al, Pt.	Ex: Fe, Ni, Co.

in the Conduction) Paramagnetism Electrons in metals)

According to Langevin's theory the paramagnetic susceptibility is inversely proportional to the temperature.

XX

But in some metals susceptibility is independent of temperature.

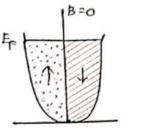
Pauli explains that it is due to the free electrons, can orient only in two directions, either along the magnetic field or against it.

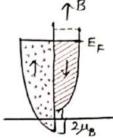
Consider a curve between density of states versus energy at absolute zero of temperature. In this spins fly with the region of curre there are two parts, one have electron spiri along z-direction and another have electron spin opposite to z direction.

In the absence of external field the distribution of electrons in the two parts are equal. :, Net mag moment of the electron gas is zero.

When a mag. field (B) is applied along z-direction, the energy of the spins aligned parallel to B is lowered by the amount up

while the energy of the Spiris opposite to B is raised by the same amount.





As a result, the Fermi level of the two spin divibution shift with respect to each other. and energetically unstable Situation

In order to acquire Stable Configurations, the es lying near the Fermi level with antiparallel parallel spins centil the two Fermilevels become equal again No. of electrons which change their direction

Neff = 12 ZCEF) MBB

where Z(FF) -> Density of states MB -> mag. moment of

The factor 1/2 is due to the fact that the density of states of one spin distribution is half of the total density of the states.

field No. of electrons? No. of electrons?

No. of electrons } No. of electron with spin parallel > with spin anti-

Since each flip increases the magnetisation by 2MB (from - 48 lottle), the net magnetisation is given by

MRNeff X2/1B = Z(Eg) UBBB

The Pauli' Spin Susceptibility

of the electron b

B=110H

From eqn, we know that Xp is independent of temp.

From FD distribution we obtain

$$Z(E_F) = \frac{3N}{2E_F}$$

N-> no. elec. per unit volume

: (3) =>
$$\chi_p = \frac{3\mu_0 N \mu_B^2}{2E_F} = \frac{3\mu_0 N \mu_B^2}{2\kappa T_F}$$

Where FF=KTF

where $\chi = \frac{\mu_0 N \mu_B^2}{kT}$ Classical susceptibility

Since To is normally very high, Yop is smaller than X by about two Orders of magnitude, which is in a agreement with experimental results.

Exchange Interaction:

The Weiss theory of ferromagnetism explains about the moleculeur field but it is not possible to explain large value of internal field.

To explain the large internal field, Heisenberg gave an explanation which is based on the non magnetic interaction called exchange interaction between electron.

These force appears in the form of spin-spin interaction and strength of the interaction depends upon the interatomic separation. If the interatomic distance is decreased, the electron spin are decreased and the exchange force decreases and become anti-parallel spins.

According to Heisenberg theory, the change interaction between electrons in different quantum. States lead to a lower energy provided the spin quantum number of the both states are parallel.

.. The exchange interaction between SQUID the electrons in given by Eex = -2 Jij Si Sj

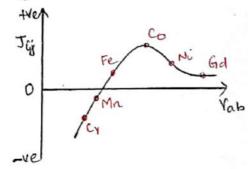
Where Jij -> The exchange integral , for the two atoms.

Si -> Spin angular moments associated with its state

Si > Spin angular moments associated with ith state.

A plot of exchange integral value (Jij) and the interatomic distance (Yab)

Yab → interatomic · distance. Yo > the orbital radius of electron



From graph, 1. The value of Jý is the when Yab >3 (i) the exchange energy is -ve and hence the parallel orientation as shown in figure. is high. Due to this atom possess ferromagnetic properties [Ex; Fe, Co, Ni Go] applied perpendicular to the 2. The value of Jij is -ve when Yab (0 (ie) the exchange energy is the induced at the two Josephson and hence the atoms coming under this criteria prossess anti-ferromagner produces the interference pattern properties [Ex: Cr, Ma]

SQUID Stands for Super--conducting Quantum Interference Device. It is an altrasensitive instrument used to measure very weak magnetic field of the order of 10th testa.

Principle:

We know that a small change in magnetic field produces variation in the quantum flux.

Description and Working Magnetic field Josephson Junction) Biasing → Josephson Current Junction-2

A Sould Consists of a

Superconducting ring which ean have magnetic fields of quantum values (1,2,3.-) of flux placed in between two Josephson junctions

When the magnetic field is plane of the ring, the current is functions. The induced current and it flows arround the ring

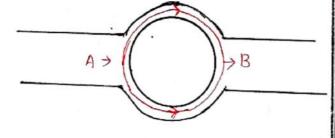
So that the magnetic flux in the ring can have the quantum value of magnetic field applied.

Application

i) sauro can be used to detect the variation of very minute magnetic signals in terms of quantum few. (ii) It can also be used as storage clevice for magnetic flux. (ii) SQUID is useful in the study of earthquakes, removing para--magnetic impurities, detection which without will increase the of magnetic signals from the brain, heart etc.

Quantum Interference Transistor.

Electrons are made to propagate through two arms of the quantum wire ring as Shown in the figure.



Suppose an electron wave enters the ring of from left to right. The wave entering through

waves. A constructive interference can be expected to occur at "B" Similar to the optical anlogue as they travel through the same distance.

The constructive interference at the output of the device reduces the resistance of the ring. Various methods of introducing a phase difference of IT between the two waves have been sugested. This leads to destructive interference rosistance by reducing the current.

An external voltage can Control the nature of interference and the current. This device is expected to act as a high speed transistor.

GMR Devices - Magnetic Hard Disky Drive wilt GMR Senson

GMR sensors, which has a very high magnetic sensitivity are used to read the data at greater Speed.

Principle:

In Hard Disk drives, the binary data in terms of zero's (o) and A' gets split up into two partial one's (1) are stored by inducing.

magnetic moment in a thiri maglayer and GMR effect 18 used as the principle to read the data wi H DD.

Heu Zero(0) represents missing transition and one (1) represents transition in the medium.

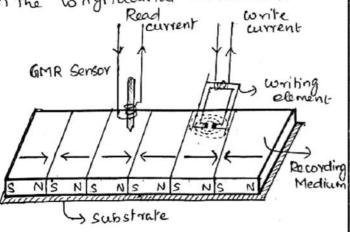
Construction:

* The HDD consists of recording medium made up of this layer of magnetic garnets grown over the Substrate the GMR Sensor.

*The substrate up made up of ferrites and anti ferromagnetic materials. This is used as reading element

up of inductive magnetic transducer.

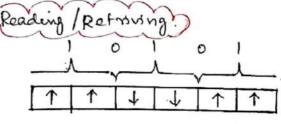
4 The writing element and the GMR Sensor Shall be made to slide over the recording media in the longitudinal direction.



Working :-Cwritin

1. Initially the current is passed through the writing. element and a magnetic field is induced in between the gap of the inductive magnetic transducer.

- 2. During writing , the amplitude of current is kept Constant, and the direction of current is reversed.
- 3. Due to reversal of current the reversal of current, the magnetization orientation is reversed in the recording medium (ce) from south -> North.
- 4. When the induced magnetic * The writing element is made field is greater than the Coercinity of the recording media, then data is recorded in the form of 1.
 - 5 Thus one (1) is Stored as data In the recording medium as a magnetic transition.
 - 6. When there is no magnetic transtition, then it is referred as cero.
 - 7. In this way 0's & 1's are Stored in the recording medium



1. GMR effect is the principle used to read/retrieve the data 2. When GMR sensor is moving hear the recorded medium, then the resistance of GMR sensor varies with respect to orientation of the magnetic moments. as follows.

* When the layer are magnetised in parallel manner their the resistance is minimum, therefore maximum current flows. This is represents. the data as one (1)

in antiparallel manner, then the resistance is maximum, therefore minimum (no current) current if lows.

This is represents the data as zono co)

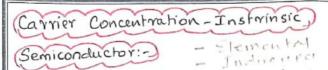
3. Therefore, with the help of the reading current, the zero's co's and one's (1's) can be retrieved from the magnetic hard disc.

Advantages;

- * Very large Storage capacity.
- A Compact in Size.
- * Non diffusive & very senstive in reading.

Dis ad vantages

- * HDD is slower than SSD
- * Consume more power
- of Data may be corrupted, due to thermal radiation.



The no. of Charge Carriers per unit volume of the material is called carrier Concontration also known as density of charge carriers.

Derivation;

intrinsic Semi concluctor the no- of electrons in the Conduction band (n) and holes in the valence band (p) is equal to each other at Took.

The density of electrons in the conduction band on is given

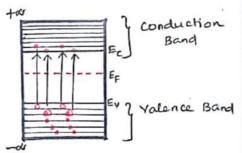
by
$$\int dn = n = \int z(E) F(E) dE$$

$$E_{C} = -(1)$$

He know that, Density of energy States

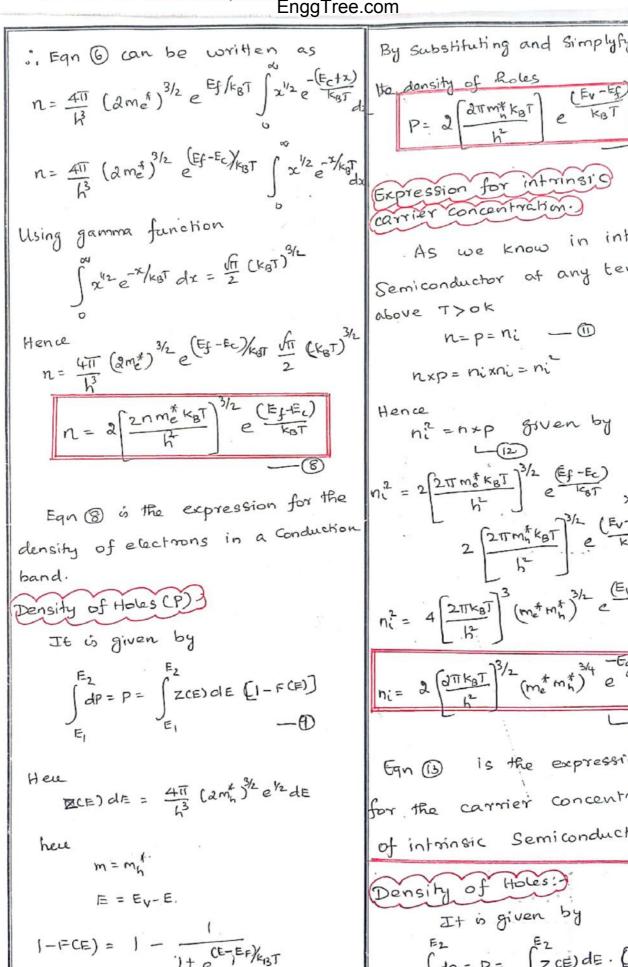
Probability of Electron occupation

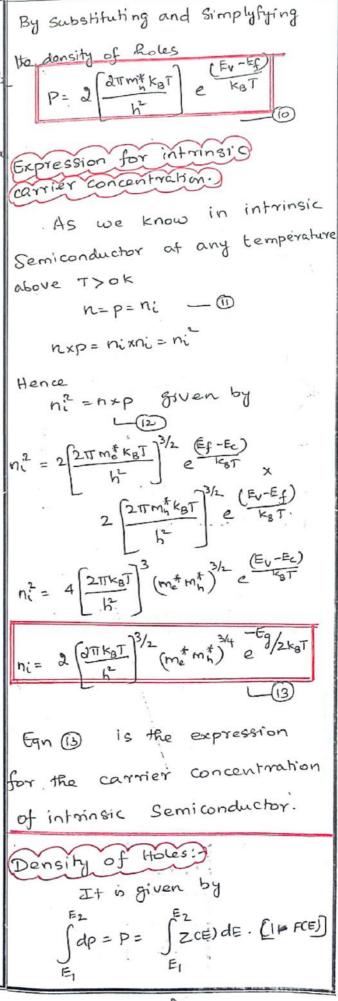
$$F(E) = \frac{1}{1 + e^{\left(\frac{E - E_F}{k_B T}\right)}} - 3$$



 $E = E_c = X$ $E = E_c = X$ $E = \infty + E_c$ $E = \infty + E_c = X$

de=dx





Here
$$Z(E) dE = \frac{4\pi}{L^3} (2m_h^*)^{3/2} E^{1/2} dE$$
Here $m = m_h^*$

$$E = E_V - E$$

$$1 - F(E) = 1 - \frac{1}{(E - E_F)/k_BT}$$

Let

$$E_V - E = X$$
 When

 $E_V - E = X$ $E_V - (-\omega) = X$ $E_V - E_V = X$
 $E_V - E_V = X$ $E_V - E_V = X$
 $E_V - E_V = X$
 $E_V - E_V = X$

Eqn @ becomes
$$P = \frac{4\pi}{13} \left(\frac{2m_h^*}{k_BT} \right)^{3/2} e^{\frac{(E_f/k_BT)}{k_BT}} \int_{x^{1/2}}^{x^{1/2}} e^{\frac{(E_f-x)}{k_BT}} dx$$

$$P = \frac{4\pi}{13} \left(\frac{2m_h^*}{k_BT} \right)^{3/2} e^{\frac{E_f-E_f}{k_BT}} \int_{0}^{x^{1/2}} e^{\frac{x^{1/2}}{k_BT}} dx$$
Using hamma function
$$\int_{0}^{x^{1/2}} e^{\frac{-x^{1/2}}{k_BT}} dx = \frac{\sqrt{\pi}}{2} \left(\frac{k_BT}{k_BT} \right)^{3/2}$$

Hence
$$P = \frac{471}{h^{3}} \left(2m_{h}^{4} \right)^{3/2} e^{\frac{E_{v}-E_{f}}{k_{B}T}} \frac{11}{12} \left(k_{B}T \right)^{3/2}$$

$$P = 2 \cdot \left(\frac{2\pi m_{h}^{4} k_{B}T}{h^{2}} \right)^{3/2} e^{\frac{E_{v}-E_{f}}{k_{B}T}}$$

$$e^{\frac{1}{12}} \frac{1}{12} \left(\frac{E_{v}-E_{f}}{k_{B}T} \right)^{3/2}$$

The above equation is the expression for the density of holes in the valence Band.

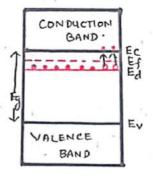
Impure Semi conductors are the one in which charge carriers generated by adding impure atoms (CEV-E) 2 e 1/8 de to the pure semiconductors.

> Types: These are classified into two types based on the type of impurity

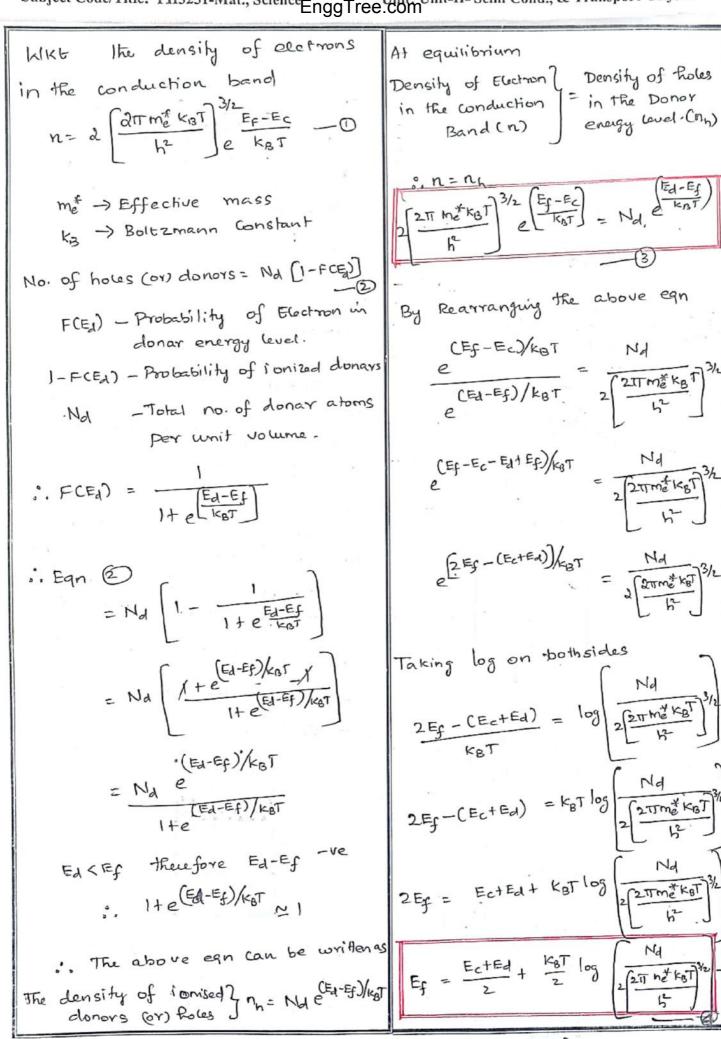
- (i) n type (penta velent impurity)
- (i) p type (Trivalent impurity)

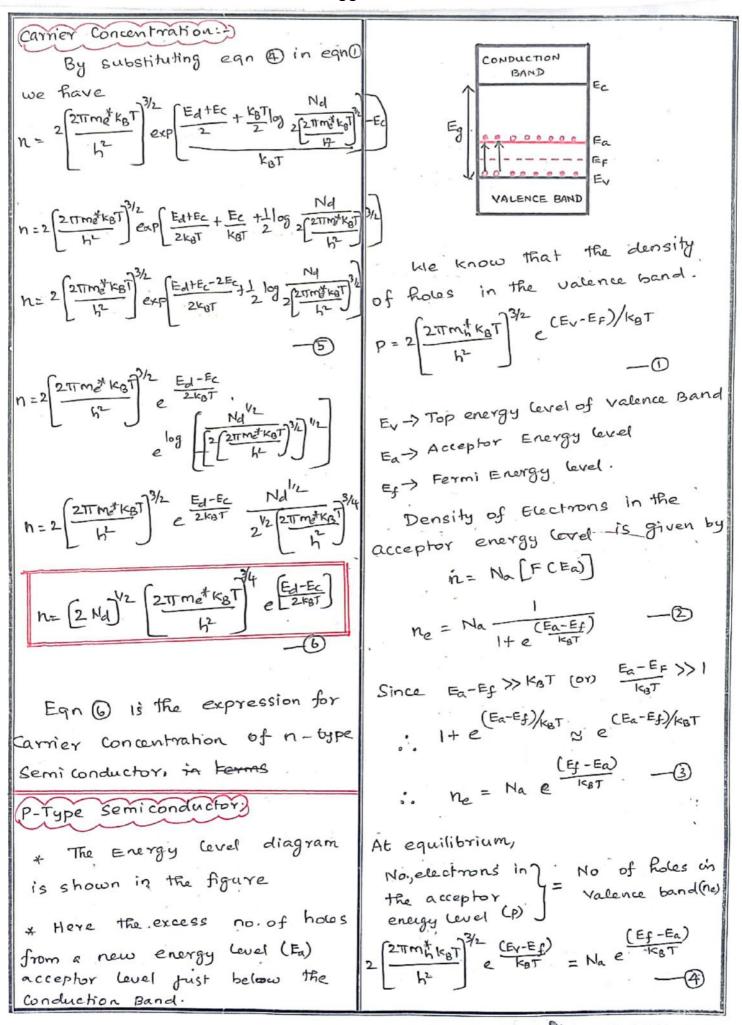
Parrier Concentration - n type Semiconducts

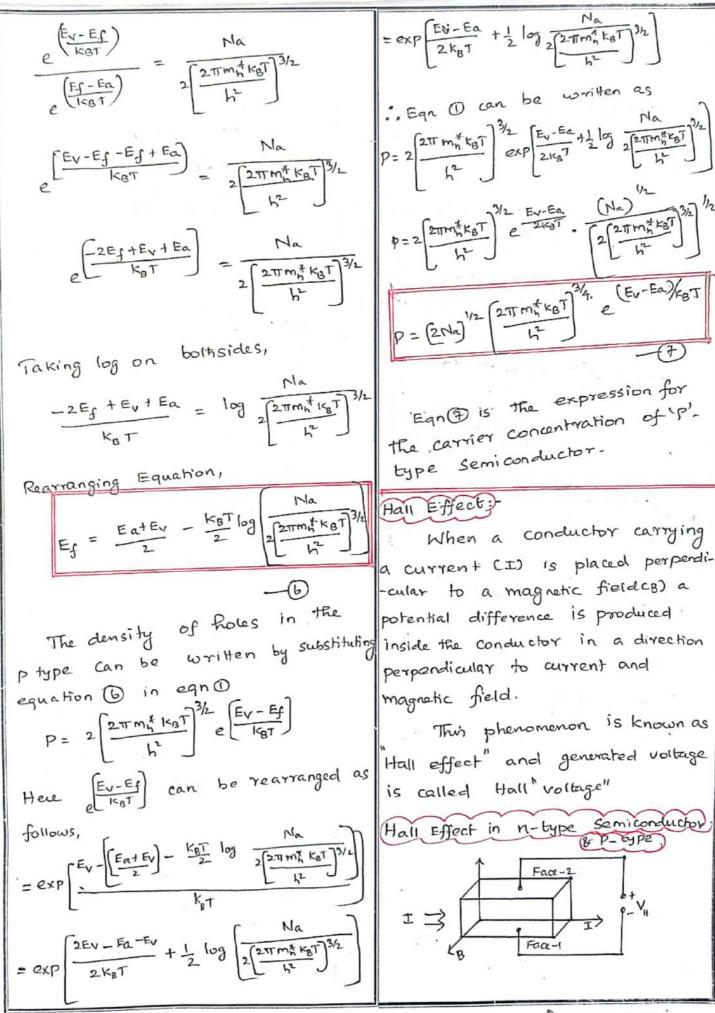
* The energy level diagram is shown in the figure.



The energy level of excess electron is called donor energy (evel (Ed). This is located above valence band.







Consider n-type semiconductor in the form of rectangular slab. Current (I) flow in X-direction magnetic field (E) is applied in Z-direction, Due to Hall effect Voltage devolped along Y-direction (in fig), current flow due to electron flow.

Electrons moving with velocity b, experience downward force

At equilibrium 0=2

BeV =
$$e E_{\mu}$$
 I $e E_{\mu} = B e - 3$

we know that

Current density

$$J_{x} = -ne\theta$$

$$\theta = -J_{x} - \Phi$$

$$ne$$

Substitute ogn @ in ogn 3

$$E_{H} = R_{H}J_{X}B$$
 S where $R_{H} = \frac{1}{ne}$

.. Hall coefficient

$$R_{H} = \frac{E_{H}}{J_{x}B}$$

Elec field in -ve Yaxis

Illy in P-type Semiconductor Current flow due to flow of holes Compare with n-type semiconductor current density Ix : per

v= Jx -6

Substitute egn (un 3)

EH = RHJZB -F

RH = 1

Hall coefficient interms of Hall voltage

Hall voltage VH = EH t_(8) where EH > Hall field.

Substitute egn (7) wi eqn (8).

Area of the Sample A = thickness x Brendly

current density Jx = Ix J = Ix - (1)

Substitute egn (1) in egn (1)

$$V_{H} = \frac{R_{H} \text{ Tx Bb}}{\text{bt}}$$

$$V_{H} = \frac{R_{H} \text{ Tx B}}{\text{bt}}$$

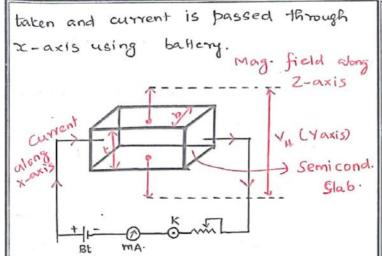
$$R_{H} = \frac{V_{H}b}{R_{H}B} - (2)$$

lign @ gives hall coefficient in.

-ve sign indicates interms of hall voltage.

Experimental Determination of Hall Co efficient

A semiconductor Slab of thickness 't' and breadly b' is



The slab is placed between poles of an electromagneti. Magnetic field is applied along z-axis. The Hall voltage CVH) is measured by placing two probes at the centre of the top and bottom of the slab.

By measuring Hall voltage, Hall Coefficient 15 determined from the

formula $R_{H} = \frac{V_{H} b}{T_{H} R}$

Mobility of charge Carriers:

We know that , Hall coefficient

$$R_{tt} = -\frac{1}{ne}$$

The above expression is valid only for conductors, where the velocity is taken as drift velocity.

For n-type Semiconductor

$$R_{H} = -\frac{1.18}{ne}$$

$$ne = -\frac{1.18}{R_H} - 0$$

For p-type Semi conductor

Electrical conductivity

for n-type Semiconductor For p-type Semicond.

Je = neyle - 3 Oh = Perh

-(6)

Application of Hall Effect:

(i) Used to determine whether the material is p-type or n-type Semiconductor.

(ii) used to find the carrier

Concentration

$$n = \frac{1}{eR_{H}}$$

(ii) used to find the mobility of Change carriers

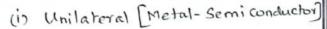
Schottky Diode:

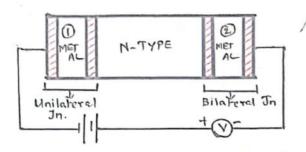
unilateral device, in which current flow from metal to semiconductor in one direction.

Construction

A Schotky diode also called as Schotky barrier diode. It is made up of 2 Juchtions.

EnggTree.com

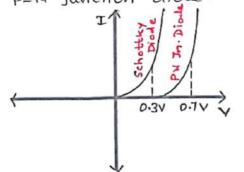




The Schottky diode act as a terminal device in which metal I and Semiconductor formed at one end act as anode with unilateral function, metal 2 and Semi conductor formed at other end act as cathode with bilateral Junction.

Morking;

Applying forward bras, the Voltage applied to diode and their Corresponding current is measured The V-I curve is drawn for Schottky diode as compared with P-N Junction digde.



As per V-I curve, during forward bias for a Schottky diode I increase enormosly even for

(i) Unilateral [Metal-Semi conductor] small applied V, due to 3 component (ii) Bilateral [Metal-Semiconductor] of current occurs in schottky diode

Application?

* Due to low voltage drop, they are used in high switching system

A they are used in BIT

* It is used is Radio frequency application.

* It is used in high power supply

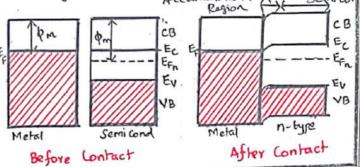
Contacts: Ohmic

Definition?

An ohmic contact is a type of metal Semiconductor function. It is formed by a contact of a metal wilt a heavily doped Semi conductor.

When the Semiconductor has a higher work function than that of metal, then the function formed is called the ohmic function.

The current is conducted equally in both directions. Bulk Accomulation () Service



Morking?

Fermi levels of the metal and Semiconductor are at different positions before contact. (Fig (i))

After contact, at equilibrium the electrons move from the metal to the empty states in the conduction band of Semiconductor.

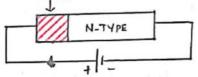
... An accumulation region near the interface is appeared. (Semi--conductor side)

shown in (fig(ii)).

Accumulation region has a higher conductivity than the bulk semiconductor due to higher concentration

Ohmic contact behaves as a Yesistor conducting in both forward and Yeverse biase. (Fig. (iii).

The resistivity is determined by the bulk resistivity of the Semiconduction.



V-I characte ristics!

Negligible
Yoltage
drop

O

The current density is propertional to the potential across the function.

Ohmic contacts are nonrectifying and show negligible voltage drop and resistance irrespective of the direction and magnitude of current.

Applications

The use of ohmic contact is to connect one semiconductor device to another, an Ic or to connect an Ic to its external terminals

Unit: W-Optical Properties of Materials

OPTO ELO MICS DEVICE - LIGHT DECTORS:

* Opto electronic devices such es light dectors (or) photo dectors are the devices which convert the light signal unto electrical Signals.

* The Three main photo detectors used in optical fiber communication System are

(i) P-i-n-Photo cliocle (PIN Diocle)

(ii) Avalanche Photo diocle (APD)

(iii) PN junction photo dector

- P-i-n-Photo Diode (PIN Diode)

* Principle:

· This Diode works in Reverse bias. Under deverse bias, light is made to fall on neutral region.

· Electron hole pairs are generated and accelerated by the external electric field, which oceaults in photo-current band, leaving a hole. * Construction:

· It consists of three deglar P. iound n.

· The p-n origions are made up of semiconductor material [silicon, germanium]

The interinsic region is a newbol where it is at the centre of the p-type and n-type ocegion and it is lightly doped with n-material.

· Since the p-n region is seperated by an intrinsic segion (i), it is called as positive-intrinsic-negative (P-i-n) photo diade.

Working:

*The PIN Diode is given very high sceverse bias to altract le charge carriers from le intrinsic region.

* The photon incident on the intrinsic oregion produces electron-hade pais, by the transfer of electrons from Valence band to conduction

* The movement of electrons in the conduction barrel creates flow of charges. Hence light energy is Converted into electrical energy

Sow Cell:

* Pounciple:

A solar cell is basically a P-N
junction photo dicele, which converts
solar energy (light energy) unto
selectrical energy. With larger
efficiency of photon absorption.

* The symbol of the solar cell
anode () catacle.

* Construction:

o A solar cell is made up of a heavily deped 'p' and n" type material

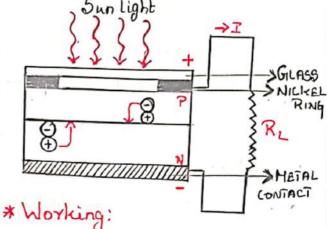
The P-N diode is packed in a can with glass window on top such that light may fall upon Panel N type material.

The thickness of the p-region and n-region is very small.

Therefore charge carriers generated in this region can easily diffuse to the junction.

O Nickel sing at the top and metal at bottom art as terminals

O The two tomics connected to the load resistance RL through the ohmic contacts.



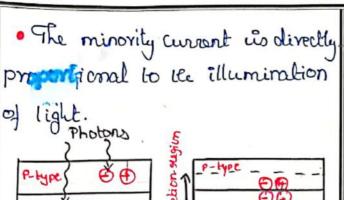
· Light radication is allowed to fall on P-N junction diade, without load resistance (Re).

• The photon energy is sufficient to break le covalent bond and produce electronhole pair.

• There electrons and holes quickly diffuses and seaches the depolation sugion.

· Therefore the strong bowlier electric field existing in the junction

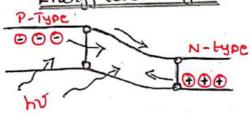
offe minority courrier electrons in the p-side cross the borrier potential to seeach N-side and the holes in N-side move to the p-side.



The electrons and holes accumulate on either side of the junction, which gives orise to open-circuit voltage (vo).

Load Resistance RL is connected across the clicale, reverse current Ir flows through the Circuit.

Energy level Diagram



* Merits:

- Outlize renewable energy
- Eco-fociently
- @ pollulion jouce
- 1 Life time devability high.

* Demerits:

- @ Cost is very high.
- @ seasonal energy
- @ Occupies more energy.

* USED:

- @ power production.
- 1 used in artifical scientile and space probes.

LIGHT EHITTING DIODE (LED).

* Definition:

· LED is a semiconductor

P-n junction diode which converts

electrical energy to light energy

under forward biasing.

symbol.

* Pounciple:

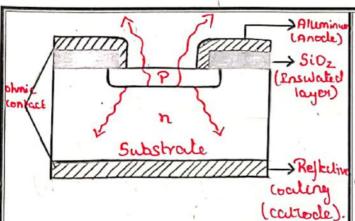
© Injection luminescence is the polinciple used in LEDS.

The injection of electrons into the p-segion form n-segion makes a direct transition from conduction bound to valence band. The electrons secombines with holes and emits photens of energy Eg

* Construction:

@ The p-n junction is formed by diffusion techniques by cloping silicon with GaAs crystal.

Obshere, n-type is grown on a substrate and a p-type layer is deposited on it by diffusion.



© To increase the modiative seccombination, the thickness of n-layer is higher than the thickness of P'layer.

O ohmic Contacts one made by aluminium in such a way that top layer "p" material is left uncovered for the emission of light, where the Carrier recombination backes place.

* Working:

O Under forward biasing, Hajority Charge curriers of n-type (electrons) moves to p-type as minority carrier

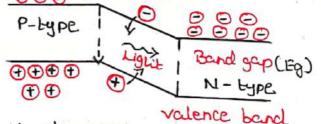
O similarly, majority charge carriers of p-type (holes) moves to M-type as minority carriers

By this process, excess of minority carriers are injected in both p and n segion, This is called minority carrier injection.

Biasing voltage in further increased, excess minoritatings Cerriers diffuse away from the junction and directly secombine with the majority corriers.

OTherefore electron-hole recombination process occurs, thereby photon is emitted.

Energy level diagram:



* Merits:

· Very fast Response.

· Cost is very low.

· Smaller in Size.

· Long life time.

* Demerils:

· power output is low

· Less Directional.

· Intensity in lesser tran laxer.

* Applications:

· used in display devices.

· Used in pilot light.

· Used in indicator lamp.

· IR LEDS used in wore-less communication.

LASER DIDDE:

* Definition:

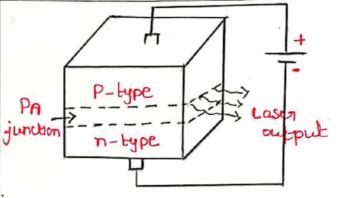
It is a specially Jabricated P-n jurction diede. This diode emils laser light when it is forward-biased.

* Pounciple:

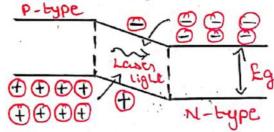
* Construction:

Recombination of electronhole pais leads to emission of light in forward biasing known as recombination radiction.

- 1 The active medium is a P-n junction diode made from * Working:
- a single crystal of GaAs.
- @ The Crystal is cut is the form of platelet (0.5mm-thick ness) Consists of two origions n-type & p-type.
- 1 Metal electrones are Connected to both upper a lower of The origin around junction surfaces of the S.c diode.
- @ Forward bias voltage is applied through metal electrodes



- ⊙The photen emission is stimulated in a very thin layer of projunction.
- @ The end Jaces of the Pn jurdion are well polished and parallel to each otter.
- 1 It acts as an optical seesanator through which the semitted light comes out.
- O when the pn-junction is Jornand biased.



- @ Electrons & holes are injected unto junction segion.
- contains a large number of electrons in the Conduction bound and holes in Valence band

@ During secombination, light photons are produced.

1 During Forward bias Voltage is increased, more photons are emilted.

@ These photons trigger a Chain of stimulated execombination more photens in phase basel forth & back of by two polished surfaces of junction.

@ After gaining enough strength Laser beam of wavelength 8400 À cis emilled from le junction. Eg=hc/x,

* Merits:

1 Compact in size.

1 High efficiency.

@ Less power Consumption.

· Waveform is Continuous/ pulsed.

* Demirk:

@ Output has large divergence * Pour ciple:

@ poor coherence & Honochromatily

* Applications of laser diades;

1 Used in optical communi

1 Used in Barcode Header.

1 Used in pointing irdusty.

O used as writing head in Disc drives.

@ Used in Various Industry applications such as cladding welding etc.

OLED - Daganic LED:

* Definition:

@ DLED are solid state devices made up of this films of organic molecules that produce light with the application of electricity

@ It is also known as light emitting polymers (LEP) or

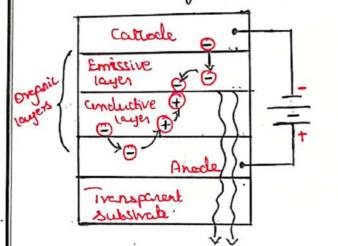
Doganic electro luminescence

@ Thickness of these layers is around 100-500 nm thick.

. An electron moves from the catrode to the emersive layer and hole moves from the anothe to the conductive layer and they recombine to produce photons.

* Construction:

© It is constructed with different layers of polymers coated with Ovigaric Compound.



- O It consist of an emissive layer made up of poly-fluorine and a conductive layer made up of poly-aniline kept between cattode and anode substrate.
- O This estale layers placed over transporent electrode layers.

- * Working!
- @ Forward bias vollage is applied across the DLED
- Due to this controde diffuse electrons into emissive layer.
- O Anode gets an electron from Concluctive layer of produces a hole in Concluctive layer.
- Others, emissive layer becomes rich in negative charged Particles & conductive layer becomes such in positive charged particles.
- Due to the selectrostatic force, electrons and holes, come closes & seccombine with each other.
- Den organic sc, holes mares fastes their electrons.
- Offis recombination produces light and it is emitted through the transparent substrate.

* Herits:

- @ 3t is thin & flexible.
- 6 Light weight
- 6 Larger field View
- @ Emission is brighter than normal light (LEDS).
- * Demerits:
 - 1 Harmacturing cost is high.
 - @ Easily damaged.
 - @ Haintainence is high.
- * Application;
- ocalios, digital camers.
- O Used in TV screens, Computers displays, adverti--Sing
- @ Automative dash boards.
- 1 Used in flexible display boards.

ELECTRO-OPTIC MODULATORS . ;

* Electro-Optic Effect:

The phenomeron in which the optical properties of a material change in desponse to a varying electrical field is known electro-optic crystal. as electro-optic effect and the Crystals with special optical properties that allow an electrical signal to combrol and modulate a beam of light are known as Electro-optic modelators.

Types of electro-optic modulatos

Base on type of the modulated beam, electro-optic modelaters are classified as

- * Intensity modulator.
- * phase modulator
- * Amplibude modulator
- * Polovization modulator.

* Pounciple:

Electro-optic modificators Consists of a non-linear Crystal [littium risberte]. The vegractive

index varies with strength of the applied electric field. Based on the linear electro-optic effect.

* Operation:

* A voltage applied across the

Electro-optic signal

* Due to plane-polarized light propagating through the crystal to resolved with two components.

* The charge in retardation between trop components is proportional to the magnetuce of the electric field.

* A crossed polarizes analyzes the output beam, resulting in intensity moderation.

* significance:

- · Hodify the properties of a travelling light wave.
- * Application;
 - · Communications.
 - ! Information processing,
 - Digital signal processing.

* Poroposties of electro-optic

· Large charge in refractive index per volt.

- · High optical quality and bransmission.
- · Las dielectric constant.

PLASHONICS:

* Plasmon:

Plasmon is a collective wave where billions of electrons oscillate in synchronization.

* Plasmonias:

plasmonics defens to the sessonant interaction between electromagnetic readiation and free electrons at the interface between a metal and a dielectric material.

* Pounciple:

Surface Plasmon Resonance High intense photons and free electron intraction courses

generalian of density electron waves called surface plasmons.

* Conduction electrons en lle nanoparticle surface of the plasmonic material undergo a Collective oscillation when excited by light at specific coardengths.

* This escillation, which is known as surjace plasmon sursonance (SAR).

*Theory:

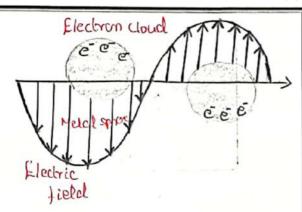
* The plasmon susonance of the force electrons in the metal nanopositicle, studied by polariza - bility.

* when an excitation occurs, the electrons will merciflete by external exectric field.

* On metal's surface : plethons will oracke each other to excilate.

After excitation waves will cappear [Longitudinal & damping]

* Surface plasmons polaritors resumance, controlled by size.



and optical properties of nanoparticle composition and medium in which the particles are embedded.

* Application:

* Superfast optical computers

* Tumor killing councer therapies

* Laser for self-driving

Switching Devices

The opto-electronic switching clevices are very useful for computing and light activated logic gates applications.

* Definition:

Switching refers to a phenomenon in which transmission of an optical field through a device is switched among two or move possible states by optical

means.

* Types of Optical switching:

There are two types of optical switching.

* P-i-n[Hulti Quantum Well]

· self electro optic effect (SEED) device.

*The Quantum controlled Stark Effect [QCSE]

* Self Electro Optic Effects
[SEED]

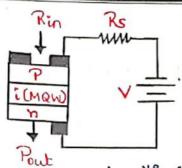
* Pounciple:

The photocurrent flowing through the current including series sussistor, changes the voltage across the modulator, this influences its absorption and transmission.

* Circuit:

* In p-1 (Maw)-n diade, by the occurred bias voltage, the tunneling current varies.

* The photocurrent-bias voltage exhibits Negative differential. Desistance (NDR).



* SEED circuit with socies resistor

* Pin -> incident optical power

Poul = I2Rs us electric output power.

* I is the photo current flowing through resistance (Rs)

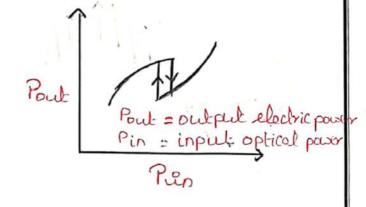
* Operation

* The photo current increases clue to seccombination of electrons and holes [tunneling of charge carriers]

* The negative bias across
the diade decreases. The heavy
hade absorption peak is shifted
to higher energies.

* Voltage drops I2Rs across the series resistor increases.

* when the photo current decreases and correspondingly output electric power decreased.



* Increase of input optical
pases increases the output
electric power due to ordinary
photon absorption by the diode.

* Photonic switching can also illustrated with two beams, one for transmission and one for Control.

ZENER - BLOCH OSCILLATIONS;

It denotes the oscillation of a particle (electron) Confined in a periodic potential whom a Constant force is acting on it.

Derivation:

for 1-D equation of motion for an electron in General electric field E $f = \frac{dP}{dt} = -eE \longrightarrow 0$ $P = R/\lambda$ $P = R/\lambda$ $P = R/\lambda$ $P = R/\lambda$ $P = R/\lambda$

$$\frac{\partial f}{\partial t} = -\frac{eE}{h}$$

Integrale He Cyn. 3

K(t) = K(0) - Et

Websity of the electronis" """

Velocity of the electronis" """

V(4) = \frac{1}{4} \frac{dE}{dIE}.

Whene $\xi =$ Energy band $\xi(k) = \Lambda$ (as a k.)

When $\alpha =$ lattice $\Lambda =$ Constant

The election position 's"is

$$\begin{cases} x(t) = -\frac{A}{eE} \cos\left(\frac{aeE}{t}\right) \end{cases}$$

... Angular fraguency & WR = aeE.

RESONANT TUNNELING:

Transmission probability of the double symmetric barrier is maximum and hence, the tunneling current reaches peak value when every of election wave is equal to quantised every state of the well.

COULOMB - BLOCKADE EFFECT !

The charging effect which book block the injection or rejection of a trigle charge into or from a quantum dot is Called Coulomb Blockado Effecti"

SEMICONDUCTOR PHOTONIC

STRUCTURE:

Photonic Structure Hat are mode up of semiconducting material are allal Soni anductor photonic Structure.

Photonic structure are building black for many optical application is veguined which, light manipulation is required in optical filtering, laring, light emilting diode and photovaltaics.

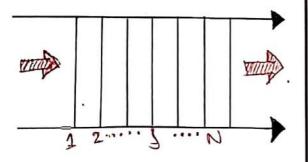
They have three directional periodic Structure, 1D, 2D, and 3D pholinic Crystal.

There are '3' type of photonic

Crystal.

1) 1D - Photonic Crystal 11) 2D - Photonic Crystal 111) 3D - Photonic Crystal

i) 1-D Photonic Crystal:



A Bragg Grating is a Onedimensional virtual medium, whose
refractive index has periodic modulation
Thin film layer of metanial of
different dielectric Constant are periodically
deposited.

A Bragg Grating is an example

for this type of photonic Crystal.

10 2D - Photonic Crystal;

Fi 2D photonic Crystal is a two-dimensional virtual medium whose refractive index is periodically redulated

in two dimension.

The Haley fiber or Photonic Crystal

000000 000000 000000 C.S of 2D Crystal.

for 2 D- Photonic Crystal.

A Dielectric material duy with a periodic lattice Containing deep and parallel Crylindrical Rules are formed.

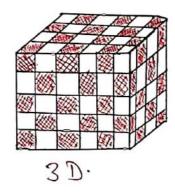
The wave propagation is being

Considered along clirection normal to the Roles.

111) 3D - Protonic Crystal :

The dielochic Constant in made to vary periodically in 3D dimensions.

In this photonic crystal, photonic bandgap prohibits electromagnetic propagation This photonic crystal is the efficient fabrication of large-dimension crystal with high refractive index variation.



OPTOFLECTRONIC DEVICES!

Oplics and electronics lighter

form a new branch of Study Called us

optoelectronics, which include the derign

and manufacture of a hardware derice

that Converts electrical energy into light

energy and vice-verse through semicenductor

There are two type of

apla ele chronic device.

i) Active optoeloctronic Device

11) Passivo aptuelectronic Device

i) Active Device:

The light interestly and be directly varied in accordance with applied input vallage source the external light is not needed for the curring.

g'i) LED
ii) later Diode

ii) Passive Device:

The light intensity is not clarged by Centralling voltage. On the offer hands the plane of polarisation is turned by the application of Central voltage:

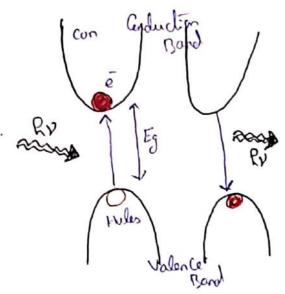
eg. Ken Cell NLO Crystal.

8) The external light source such as polariser and analyser are required.

PHOTO PROCESSES:

The operation of optoelocheric devices is based on the creation of election of election. As election-habe pairs so called photo process' & Photon with sufficient energy are absorbed the election-habe pair are created in Cornior Cereration.

The veverue process is electron-Rale vo Combination, give up its energy is Charges Re Combination



Charge Coneration & Re Combination

The recombination may be two type

i) Non-vadiative Process

ii) Radiative Process.

i) Non-vadiation proby:

The excess energy due to re Combination is usually impossed in the form by Photon and dissipated in the form as Roal in Radialise Process:

The excess energy is The excess energy is dissipated as photon usually having energy energy barries pated as photon usually having energy equal to band gap, enith light.

QUANTUM CONFINEMENT:

It is a process of reducing the size of a Cubic solid, so Hat the energy level inside becerne descrete.

@ It is observed when the size of the particle is too small Compare to He wave length of the electron.

@ In which only small percent of electron free to more during Confinement. & By bottom up or Top down process the dimension reduced.

QUANTUM STRUCTURE:

When a bulk material reduced in its size. If the reduced dimension is in the order of few renormaterials, Hen the structure is known as Quantum Structure".

It is classified into 3 types

based on direction.

1) Quantum well

ii) Quantum Wire,

· iii) Quantum Dat.

i) Quantum Well:

If one direction is reduced te nano varge while the other two dimension verain large, then we get a shirture

Known as "Quantum well". @ Quantum well are made from alternative layer of different sanianductor or by deposition of very thin metal film. @ It is a large structure in which the Carrier particle are free to

more in 2D. & The particle are Confined in one Dimention, Hey are Considered as

Quantum Confinement. @ Confinement of Carriers, the quantum well structure has important application to making devices.

11) Quantum Wive:

€ If 2D are reduced and one dimention venain

large, the resulting shirchine, well.

Quantum Wive.

The Carrier are free to move

its trajectory along the wire.

@ Quantum wire

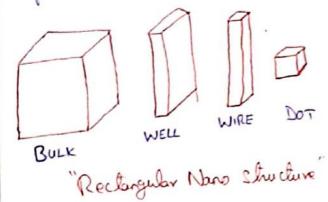
Structure are nanowire, narorod and ranolude.

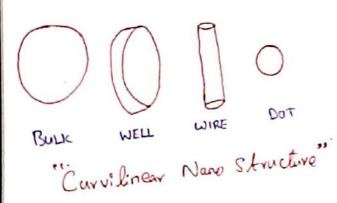
iii) Quantum Dols:

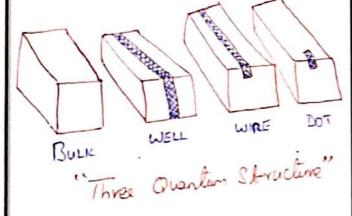
@ All three dimension are rininized, the resulting

Structure is known as Quarter Dot.

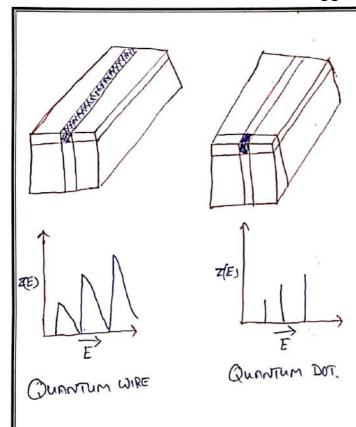
1 The Carriers has only Enfined State is not freely moving & It has many thousand of altern, Grier are Gruidered a single ation due to its peculiar properties. & It is used in a quantum amputer and quantum det later etc







DENSITY OF STATE IN QUANTUM WELL, QUANTUM WIRE & QUANTUM Bulk Structure: Dentily of & ZED = FTIJI M " (E-E) 12 Clate E => Battom of Conductor Bond Fregy M"=> Effective mans of electron. Quantum Well : @ The electron Can move freely in two dimension and Confined in only one direction Density of $z(E) = \frac{h\pi m^2}{R^2} \frac{E_0 > E_1}{1 = 1,2,3}$ Quantum Wire: & It provide only one non-Confrerent direction, it an more only one direction; the remaining two direction are Confined for Charge Garrier. 2 JZM (F-E;); i=1,2,2. Denuly of ZE) = State QUENTUM BULK ZE)



SINGLE ELECTRON TRANSISTOR: (SET)

SET is three-terminal switching device which an transfer electron from source to drain one by one.

& SET is individually antrol the turneling of electron into and out of the quantum dot.

Construction & Working:

Apply voltage bias to the gate voltage; Voltage difference occurs' between source & Drain. That the Current and electron flow in the same direction, from which the electron are orginate.

field that after the Conductivity of the seniconducting channel below it, enabling arrent to their from Source to Drain

Due to electic field, Change in potential energy in dot w.r.t to Source and Drain

difference make electron in the source attracted to the dut, Simultaneously electron in the dut attracted to the dut attracted to the drain.

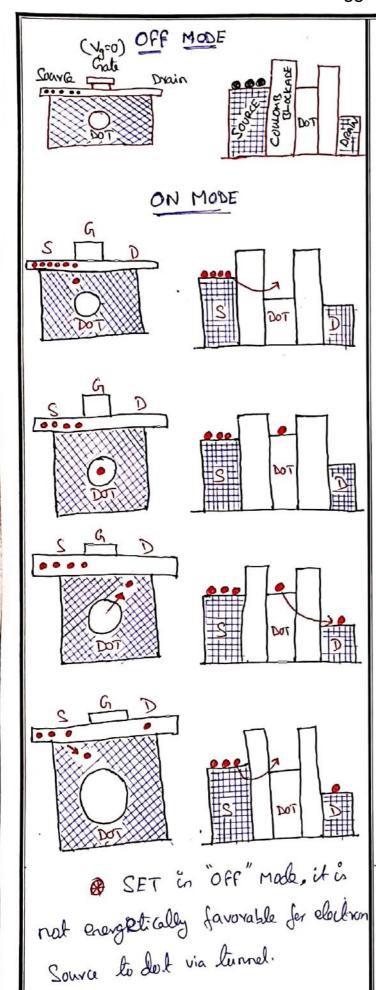
Energy need to move a charge Q, across the palential difference V.

$$V = \frac{E}{Q} = \frac{E}{Q} = \frac{W_c}{Q}$$
 $V = \frac{E}{Q} = \frac{E}{Q} = \frac{W_c}{Q}$
 $V = \frac{Q}{Q} = \frac{Q}{Q} = \frac{Q}{Q} = \frac{Q}{Q}$
 $V = \frac{Q}{Q} = \frac{Q}{Q} = \frac{Q}{Q} = \frac{Q}{Q}$
 $V = \frac{Q}{Q} = \frac{Q}{Q$

This ruch of vallage require to electron turned through Gulen's blackade of avantum dot.

Working;

The SET Ras an electrically isolated quantum dot located between the source & drain.



SET in "ON" Mode, electron turned one at a time via the dot from source to drain.

Potential energy of doct is low to encourage electron to turned through energy barrier.

The electron is on it, the dot potential energy rises as in fig.

Electron Hen tunnel through the Coulomb blockade on the other tide to reach the lower potential energy at the drain.

Over again, the process repeats.

Application:

SET is used in sensor technology and digital electronic avails

→ It is used for mans data storage.

It is used in highly sentitue

electrometer

SET is suitable measurement set-up for single election Spechusepy.

CARBON NANDTURE: [CNT]

The heragonal lattice of Carbon & Simply graphile. A single layer of graphile is Called Graphene.

When the graphene layer is rolled, the shutture is tube like and it is a single recloude, and is made up of a hexagonal net work of Grabelly bonded Carbon alon.

Type of CNT:

Three type of ranolube

Structure are Considered by rolling a graphile sheet base on aris,

i) Arm Chair Structure
ii) Zig-Zag Structure
iii) Chiral Structure.

i) Arm Chair Structure:

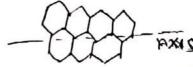
when the axis of lube parallel to C-C bond of the

ii) Zig-Zag Structure:-

James by rolling graphentais Sheet such the axis of the lube is not parallel to C-C bonds, its

perpendicular to C-C bonds.

(ii) Chival Structure:



In chiral Shucline, C- Chord is inclined towards the assis of the lube Properties of CNT:

"Electrical Properties:

Graphon nanotube are metallic or some anducting depending on the diameter or chirality.

Energy gap of sani Conducting Chiral Carbon ranalube is inversely proportional to the diameter of the lube.

The energy gap also varies

along the lube axis and reaches a minimum value at the lube end.

11) Mechanical Properties:

Carbon-Carbon bond will cultimately
Righ Strength:

properties of nanalube is ability to withstand extreme Strain

& II have high ultimate

tentile - Strongth.

is the order of 10-20 m²/g which is

Righer Han graphita. iv> Chemical Properties:

It is difficult to osidize
them and the oneset of oscidation in
ranotube is 100°C higher than that of
Carbon fibres.

is not a limitation in practical application of revolutes.

V) Thermal Proporties:

It have a high thermal and uctivity and the value increase with decrease in diameter.

Application:

@ It is used in development

of that parel display.

& It is used to make a Conjuter

Switching devices.

The Canbe used for Storing the Rydrogen, which is used in the development of Jud Call.

The Canbe used to increase

the tensile strength of Steel

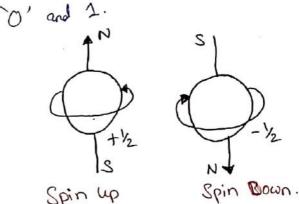
The act as Catalyst for
some chemical reactions

SPINTRONICS:

Spintronics is a NANO
technology which deals with spin dependent
properties of an electron instead of charge
dependent Properties.

Spintronics is based on the Spin of electron vather than its change.

State - Spin up and Spinchown Grs
Clockwise and antichock wise represent



Explanation:

Spining of election likes a liny magnet with north and south pale The orientation of north-south airs depends on the particle aris of Spin.

for ordinary material, the magnetic moment and to each other, but in ferro regnetic material, it

exhibits magnetic properties. This result in a permanent magnet.

Working :-

All Spintronic devices act in simple Schene;

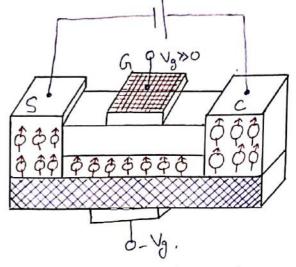
◆ Information is stored into Spin as a particular Spin orientation (up or down).

The spins, being attached to mubile electron, Carry information along a wive and He information is read at a lerminal.

Spin orientation of electron in Spintronic device cuseful for memory Storage and magnetic sensor application.

These are used for quantum Computing, electron Spin will represent a bit ((qubit)) of information. when electron Spins are alligned this electron spins are alligned this create a large 1 Gale net magnetic moment.

SPIN- FET:-A Spin based field Effect Transister ie SPIN-FET.



First the Spins Rave to be injected from source into the non-magnetic layer and then transmitted to the Collector.

The injected spin which are bransmitted through this layer start precessing as in fig., before they reach the Collector due to the Spin-orbit Coupling effect.

Hence, He net spin polorization is reduced. In order to salve this problem an electrical field is applied I've to the plane of the film by depositing a gate electrole on the top to reduce the spin-orbit Gupling effect.

If Vg is zoro, net spin polarization are reduced before they

reach the Collector.

If Vg>>0, the precession of electron is Controlled by electric field to reach the Collector with the same polarization.

By Centrolling the gale voltage and polarity, the Current in the Collector Can be modulated just like the MOSFET of the Conventional electronics.